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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

9/B Amdt
7-12-03
A-well

In re PATENT APPLICATION of

Norio Hirashita et al.

Group Art Unit: 2823

Serial No.: 09/825,973

Examiner: J. Maldonado

Filed: April 5, 2001

For: A STRUCTURE OF A FIELD EFFECT TRANSISTOR HAVING METALLIC
SILICIDE AND MANUFACTURING METHOD THEREOF

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: June 19, 2003

RECEIVED
JUN 19 2003
TECHNOLOGY CENTER 2800

Sir:

In response to the Office Action dated December 19, 2002, the period for response having been extended three (3) months to June 19, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

In the Specification:

Replace the paragraph beginning on page 1, line 4 with the following paragraph:

"The present application claims priority under 35 U.S.C. 119 to Japanese

Application No. 2000-104733 filed on April 6, 2000, which is hereby incorporated by reference in its entirety for all purposes."

06/18/2003 JBALINAN 00000086 500238 09825973

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